## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: O93721

Hans-Juergen ROSTALSKI, et al.

Appln. No.: 10/571,267

Group Art Unit: 2873

Confirmation No.: 6099

Examiner: Darryl J. COLLINS

Filed: February 12, 2007

For: LITHOGRAPHY LENS SYSTEM AND PROJECTION EXPOSURE SYSTEM

PROVIDED WITH AT LEAST ONE LITHOGRAPHY LENS SYSTEM OF THIS TYPE

## EXCESS CLAIM FEE PAYMENT LETTER

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

An Amendment Under 37 C.F.R. § 1.111 is attached hereto for concurrent filing in the above-identified application. The resulting excess claim fee has been calculated as shown helow.

	After Amendment		Highest No. Previously Paid For	d					
All Claims	24	-	21	=	3	X	\$52.00	. =.	\$156.00
Independent	3	-	3	=		X	\$220.00	=	\$.00

TOTAL.

= \$156.00

EXCESS CLAIM FEE PAYMENT LETTER

U. S. Application No.: 10/571,267

The USPTO is directed and authorized to charge the statutory fee of \$156.00 and all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account.

Respectfully submitted,

Registration No. 60,831

Attorney Docket No.: Q93721

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Date: December 1, 2008